



PATENT APPLICATION  
Docket No. 5484-089  
Client No. PX1333-US/SSM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: In-Hak Park, et al. Conf. No. 1483  
Serial No. 10/027,641 Examiner: Pham, Hoa Q  
Filed: December 19, 2001 Art Unit: 2877  
For: SEMICONDUCTOR WAFER POSITION DETECTING  
SYSTEM, SEMICONDUCTOR DEVICE FABRICATING  
FACILITY OF USING THE SAME, AND WAFER  
POSITION DETECTING METHOD THEREOF

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL LETTER**

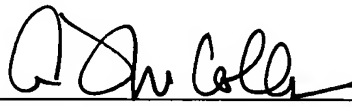
Enclosed for filing in the above-referenced application are the following:

- ☒ Publication and Issue Fee
- ☒ FOUR sheets Formal Drawings (comprising 7 figures)
- ☒ In connection with issuance of a patent:
  - ☐ Supplemental Declaration ☒ PTO Form 85B
- ☒ PTO Form 2038 authorizing credit card payment of \$1630.00, issue fee (\$1330.00) and publication fee (\$300.00) is enclosed.
- ☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

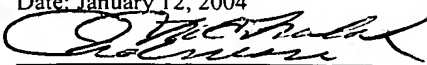
**Customer No. 20575**

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

  
Alan T. McCollom  
Reg. No. 28,881

MARGER JOHNSON & McCOLLOM, P.C.  
1030 SW Morrison Street  
Portland, OR 97205  
503-222-3613

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
Date: January 12, 2004  
  
Adrienne Chocholak